



IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Applicant: **Wu, et al.**

Case: **4658/CMP/CMP/RKK**

Serial No.: **09/583,512**

Filed: **May 31, 2000**

Examiner: **Rose, Robert**

Group Art Unit: **3723**

Title: **SYSTEM AND METHOD FOR CHEMICAL MECHANICAL
PLANARIZATION**

ASSISTANT COMMISSIONER FOR PATENTS
Washington, DC 20231

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RESPONSE TO OFFICE ACTION

In response to the Office Action dated October 25, 2001, (Paper No. 7), please
amend the above-identified patent application as follows:

IN THE CLAIMS-

Please cancel claims 1-13 and 27-43 ^{NE} without prejudice.

Please replace the indicated claims with the replacement claims as
follows:

14. (AMENDED) The method of claim 18, wherein the step of providing the
first relative motion further comprises the step of:
performing a chemical mechanical planarization process.

AM

(see interview
summary
page no 11.)